			ä
	Application No.	Applicant(s)	
Notice of Allowability	10/604,056	WILLE ET AL.	
	Examiner	Art Unit	
	Eric B. Chen	1765	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comm IGHTS. This application is:	n this application. If not included unication will be mailed in due course	
1. This communication is responsive to <u>14 November 2005</u> .			
2. The allowed claim(s) is/are <u>1-11,13-27,29-45 and 47-97</u> .			
 Acknowledgment is made of a claim for foreign priority units. a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). 	e been received. e been received in Application	on No	om the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be subm	NENT of this application.		
INFORMAL PATENT APPLICATION (PTO-152) which giv			
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.		
(a) \square including changes required by the Notice of Draftsper	son's Patent Drawing Revie	w (PTO-948) attached	
1) 🗌 hereto or 2) 🗍 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR feet)			of
each sheet. Replacement sheet(s) should be labeled as such in	the header according to 37 C	FR 1.121(d).	
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MAT FOR THE DEPOSIT OF BI	ERIAL must be submitted. Note the OLOGICAL MATERIAL.	ne
Attachment(s)	5 □ Notice of Ir	nformal Patent Application (PTO-152)	1
 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) 	6. Interview S	ummary (PTO-413),	(
3. Information Disclosure Statements (PTO-1449 or PTO/SB/		/Mail Date Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	•	Statement of Reasons for Allowance	e
of Biological Material	9.		

Application/Control Number: 10/604,056

Art Unit: 1765

REASONS FOR ALLOWANCE

Page 2

1. Claims 1-11, 13-27, 29-45 and 47-97 are allowed.

- 2. The following is an examiner's statement of reasons for allowance for claims 1, 15, and 33: the prior art fails to teach or suggest depositing a layer of barrier material that substantially blocks impurity diffusion from an underlying interlevel dielectric into an imaging material on the layer of planarizing material. The closest prior art, Tsai, teaches forming a barrier layer to protect a via contact hole from poisoning (column 6, lines 12-28). Tsai further teaches forming the barrier layer (250) on the sidewalls of the contact hole (245) (column 6, lines 53-57; Figure 2F). However, there is not motivation or suggestion of forming a barrier material that substantially blocks impurity diffusion from an underlying interlevel dielectric into an imaging material on the layer of planarizing material, as in the context of claims 1, 15, and 33.
- 3. The following is an examiner's statement of reasons for allowance for claims 52, 66, and 83: the prior art fails to teach or suggest depositing a barrier material of silicon dioxide on the layer of planarizing material. The closest prior art, Tsai, forming the silicon oxide barrier layer (250) on the sidewalls of the contact hole (245) (column 6, lines 53-57; Figure 2F). However, there is not motivation or suggestion of depositing a barrier material of silicon dioxide on the layer of planarizing material, as in the context of claims 52, 66, and 83.
- 4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

Application/Control Number: 10/604,056 Page 3

Art Unit: 1765

accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Response to Arguments

- 5. Applicant's arguments, (Applicants' Remarks, pages 20-21), filed Nov. 14, 2005, with respect to the rejection of claims 1, 15, and 33 under 35 U.S.C. 103(a) as unpatentable over Hussein, in view of Tsai, have been fully considered and are persuasive. Applicants have pointed out that the Tsai reference does not teach the claim limitation of "forming a barrier material that substantially blocks impurity diffusion from an underlying interlevel dielectric into an imaging material on the layer of planarizing material." The rejection of claims 1, 15, and 33 has been withdrawn.
- 6. Applicant's arguments, (Applicants' Remarks, pages 20-21 and 26-27), filed Nov. 14, 2005, with respect to the rejection of claims 52 and 66 under 35 U.S.C. 103(a) as unpatentable over Hussein, in view of Tsai; and claim 83 under 35 U.S.C. 103(a) as unpatentable over Hussein, in view of Tsai, in further view of Wolf, have been fully considered and are persuasive. Applicants have pointed out that the Tsai reference does not teach the claim limitation of "depositing a barrier material of silicon dioxide on the layer of planarizing material." The rejection of claims 52, 66, and 83 has been withdrawn.

Application/Control Number: 10/604,056

Art Unit: 1765

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Eric B. Chen whose telephone number is (571) 272-

2947. The examiner can normally be reached on Monday through Friday, 8AM to

4:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone

number for the organization where this application or proceeding is assigned is 571-

273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

EBC

Nov. 21, 2005

NADINE G. NORTON SUPERVISORY PATENT EXAMINER

Page 4